

Lecture 12.

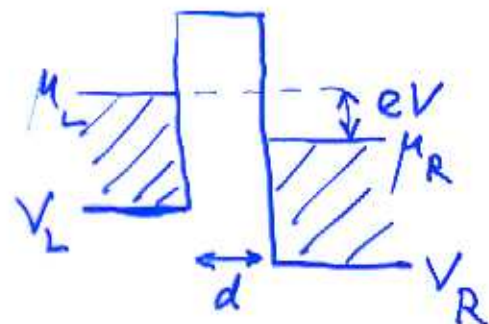
**Spin-dependent tunneling
in magnetic nanostructures**

- Effect TMR
- Spin quantum well
- Transport in ferromagnetic wires with domain walls
- Negative resistance of the domain wall

Effect TMR

1

Tunneling through
the barrier (nonmagnetic)



$$I = e \int \frac{d^2 k_{||}}{(2\pi)^2} N(k_{||}) T(k_{||})$$

$$N = 2 \cdot \frac{1}{2} \int_0^{eV} dE v_z \cdot \frac{1}{\pi v_z} = 2eV$$

$\frac{1}{2} = 1$

$$T(k_{||}) = \frac{16 K_L \alpha^2 K_R e^{-2\alpha d}}{(K_L^2 + \alpha^2)(K_R^2 + \alpha^2)}$$

$$K_L = \sqrt{2m(E - V_L) - k_{||}^2}$$

$$K_R = \sqrt{2m(E - V_R) - k_{||}^2}$$

$$\alpha = \sqrt{k_{||}^2 + 2m(V_B - E)}$$

Conductance

$$G = \frac{dI}{dV} = 2e^2 \int \frac{d^2 k_{||}}{(2\pi)^2} T(k_{||}) =$$

$$= 2e^2 \int_0^{\epsilon_m} v_z(\epsilon) T(\epsilon) d\epsilon$$

$$v_z(\epsilon) = \frac{v}{2\pi}$$

$$\epsilon_m = \frac{1}{2m} \min\{K_{LF}^2, K_{RF}^2\}$$

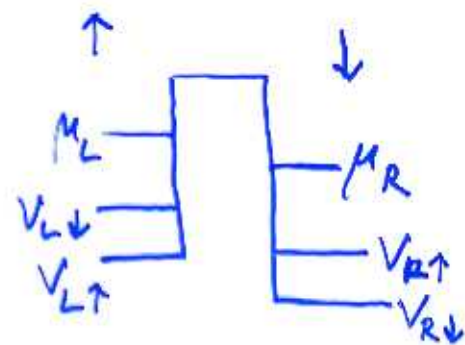
Magnetic case

$$V_L \rightarrow V_{L\sigma}$$

$$V_R \rightarrow V_{R\sigma}$$

$$K_L \rightarrow K_{L\sigma}, K_R \rightarrow K_{R\sigma}$$

$$\sigma = \uparrow, \downarrow$$



$$I_{\uparrow(\downarrow)}^F = \frac{e}{2} \int \frac{d^2 K_{||}}{(2\pi)^2} N_{\uparrow(\downarrow)}(K_{||}) T^F(K_{||})$$

$$I_{\uparrow(\downarrow)}^{AF} = \frac{e}{2} \int \frac{d^2 K_{||}}{(2\pi)^2} N_{\uparrow(\downarrow)}(K_{||}) T^{AF}(K_{||})$$

$$TMR = \frac{G^F - G^A}{G^A}$$

For $\alpha d \gg 1$ (large barrier)

$$TMR \approx \frac{2 P_{eff}^2}{1 - P_{eff}^2}$$

$$P_{eff} = \frac{\alpha_0^2 - K_{M0} K_{M0}}{\alpha_0^2 + K_{M0} K_{M0}} \rho$$

$$\rho = \frac{K_{M0} - K_{M0}}{K_{M0} + K_{M0}}$$

- spin polarization
in ferromagnet

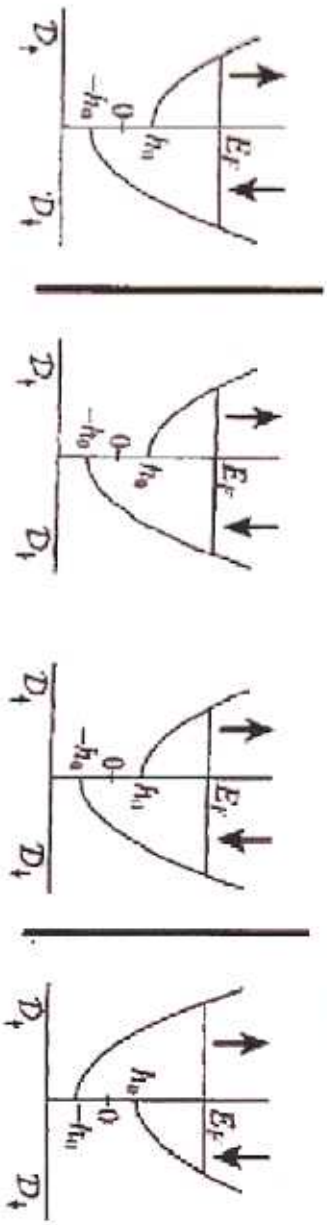
$$K_{M0} = \sqrt{2m E_{F\uparrow}}$$

$$K_{M0} = \sqrt{2m E_{F\downarrow}}$$

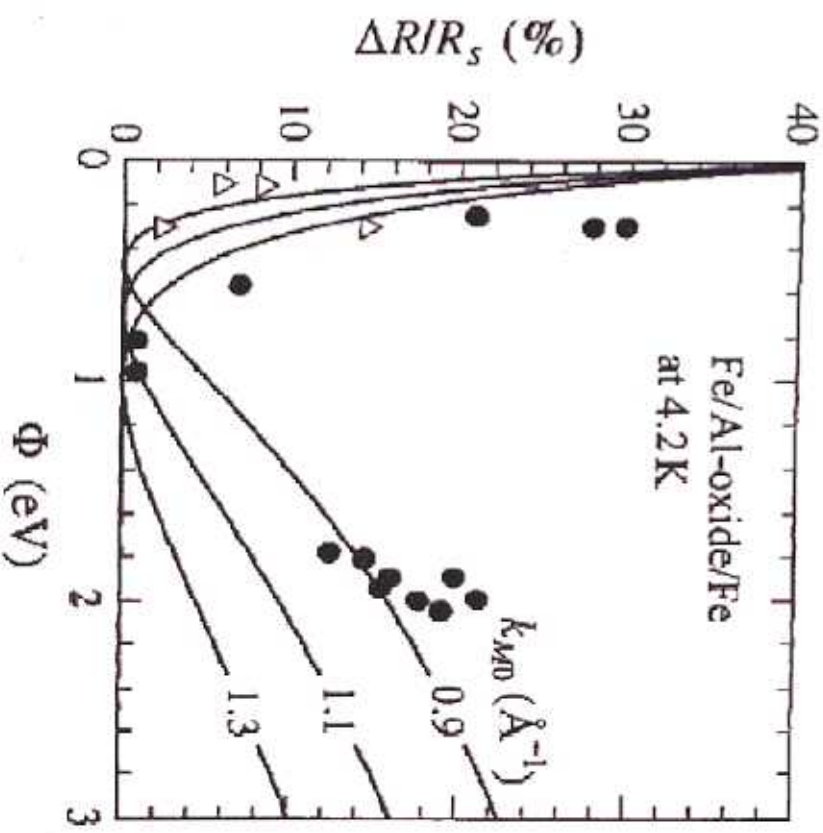
For α_0 large:

$$TMR \approx \frac{2\rho^2}{1 - \rho^2}$$

(a) F-alignment



(b) A-alignment



230% room-temperature magnetoresistance in CoFeB/MgO/CoFeB magnetic tunnel junctions

David D. Diyarprawira,¹⁾ Koji Tsunekawa, Motonobu Nagai, Hiroki Maehara, Shinji Yamagata, and Naoki Watanabe
Electron Device Equipment Division, Aneva Corporation, 5-8-1, Horiya, Fuchu-shi, Tokyo 183-8508, Japan

Shinji Yuasa,²⁾ Yoshishige Suzuki,³⁾ and Koji Ando
Nanoelectronics Research Institute, National Institute of Advanced Industrial Science and Technology (AIST), Tsukuba, Ibaraki 305-8568, Japan

(Received 25 October 2004; accepted 24 January 2005; published online 23 February 2005)

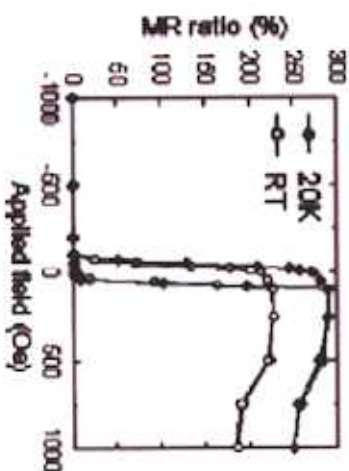


FIG. 1. MR curves of CoFeB/MgO/CoFeB MTJs evaluated at RT and 20 K.

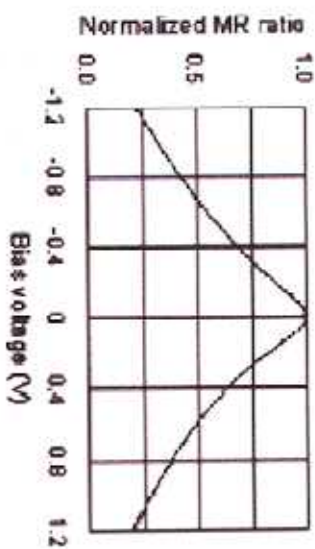
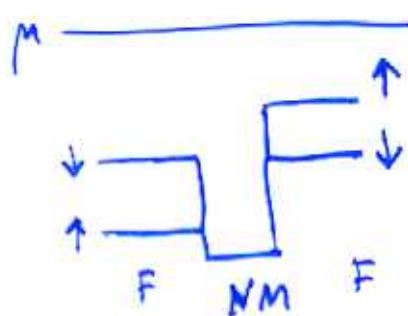
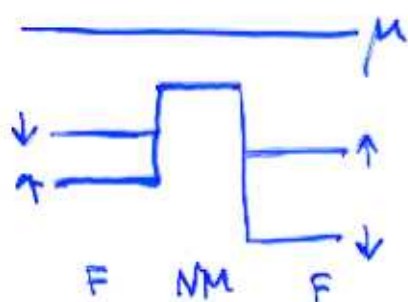


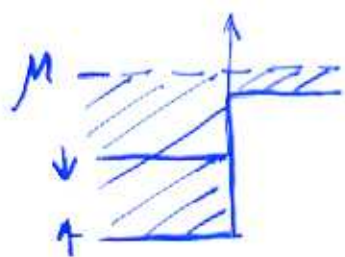
FIG. 4. Bias voltage dependence of normalized MR ratio evaluated at RT in CoFeB/MgO/CoFeB MTJs.

How to use magnetic profile?



structure with spin quantum well

Ferromagnet - Semiconductor

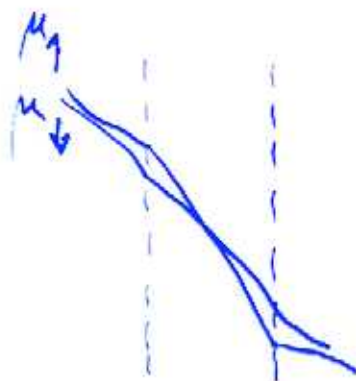
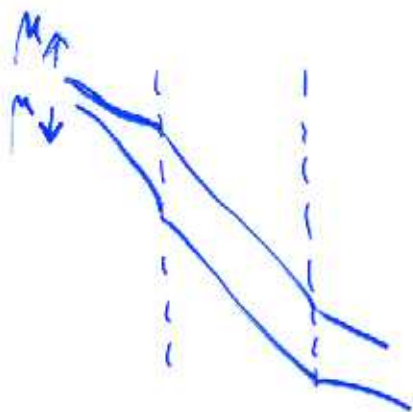


spin injection into semiconductor



Experimentally: no spin injection!

The reason is different resistivity



$$\alpha = \frac{j_{\uparrow} - j_{\downarrow}}{j_{\uparrow} + j_{\downarrow}}$$

Spin-polarized current

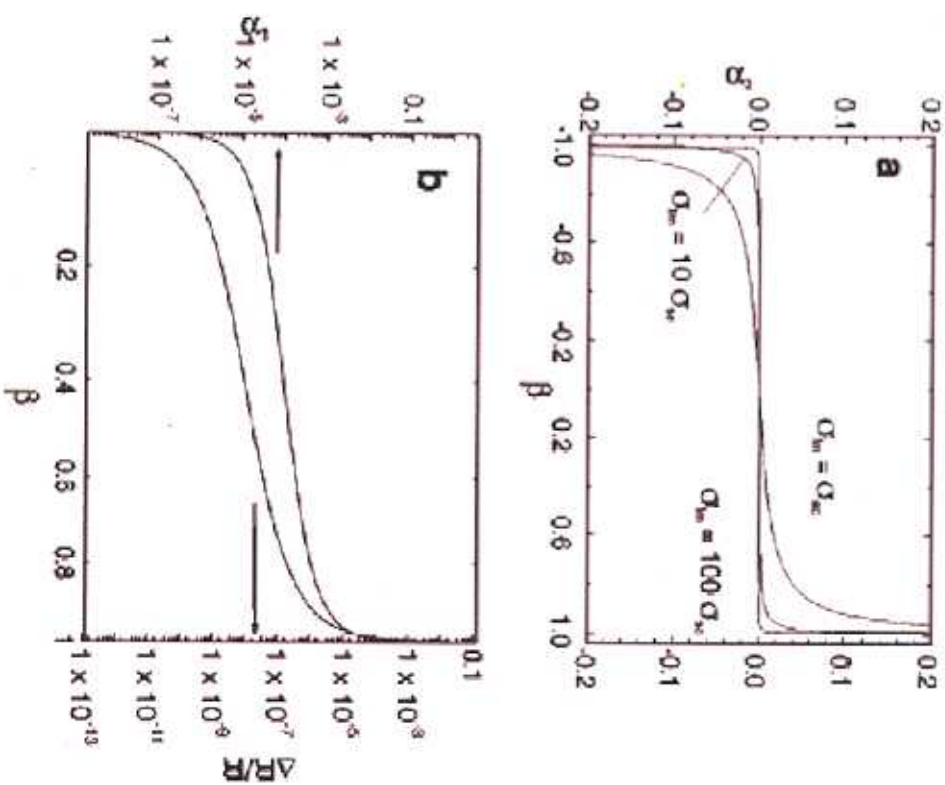
Fundamental obstacle for electrical spin injection from a ferromagnetic metal into a diffusive semiconductor

G. Schmidt, D. Ferrand, and L. W. Molenkamp
Physikalisches Institut, Universität Würzburg, Am Hubland, 97074 Würzburg, Germany

A. T. Filip and B. J. van Wees

*Department of Applied Physics and Materials Science Centre, University of Groningen, Nijenborgh 4,
 9747 AG Groningen, The Netherlands*

(Received 19 June 2000)



Ferromagnet with domain wall

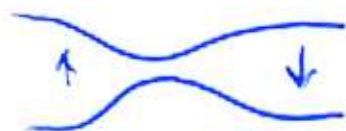
Two main types

- smooth DW, $K_F L \gg 1$ (classical ferro)

- sharp DW, $K_F L \lesssim 1$ (constriction)

$K_F L \ll 1$ (magn. semicond.)

In nanoconstriction:



$L \sim \text{at. size}$

(P. Bruno, 1999)

Applications:

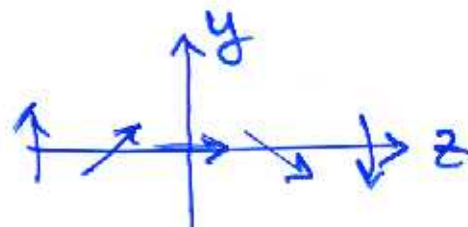
- controllable using magn. field

- easy to move

- current-induced motion

Resistance of smooth DW

$$\mathcal{H} = -\frac{1}{2m} \frac{\partial^2}{\partial z^2} - \gamma \vec{\sigma} \cdot \vec{n}(z)$$



Unitary transformation:

$$T^\dagger(z) \vec{\sigma} \cdot \vec{n}(z) T(z) = \sigma_z$$

$$\frac{\partial}{\partial z} \rightarrow \frac{\partial}{\partial z} + A_z(z)$$

Gauge potential:

$$\vec{A}(z) = T^\dagger(z) \frac{\partial}{\partial z} T(z)$$

Parametrization:

$$\vec{n}(z) = (\sin \varphi(z), 0, \cos \varphi(z))$$

$$\vec{A}(z) = (0, 0, \underbrace{-\frac{i}{2} \sigma_y \varphi'(z)}}_{\text{small for smooth DW}})$$

small for smooth DW

Semiclassical approximation

$$\varphi'(z) \equiv \beta \approx \text{const}$$

$$H_{\text{eff}} \approx -\frac{1}{2m} \frac{\partial^2}{\partial z^2} - \mu \sigma_z + \frac{m\beta^2}{2} + i \sigma_y \beta \frac{\partial}{\partial z}$$

Conductivity

$$\sigma_{zz} = \frac{e^2}{2\pi m^2} T_2 \int \frac{d^3 k}{(2\pi)^3} (k_z - m\beta \sigma_y) G^R (k_z - m\beta \sigma_y) G^A$$

Resistance of DW can be negative

(and very small!)

PHYSICAL REVIEW B 66, 020403(R) (2002)

Ballistic magnetoresistance over 3000% in Ni nanoccontacts at room temperature

Harsh Deep Chopra* and Susan Z. Haas

Thin Films & Nanosynthesis Laboratory, Materials Program, Mechanical & Aerospace Engineering Department, State University of New York at Buffalo, Buffalo, New York 14260

(Received 30 April 2002; published 26 June 2002)

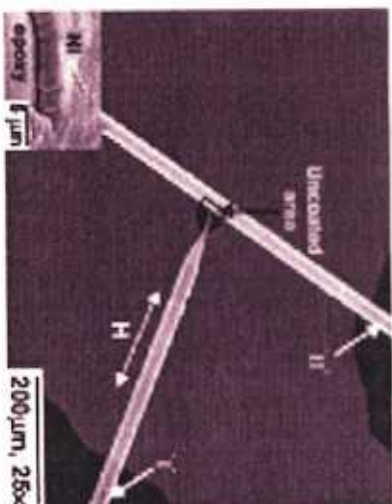


FIG. 1. Scanning electron micrograph of the 125- μm -diameter Ni wires in a T configuration. The electrodeposited Ni nanoccontact is deposited in the gap between the tip of the Ni wire labeled I and the wire labeled II. The inset shows the columnar growth of the electrodeposited Ni.

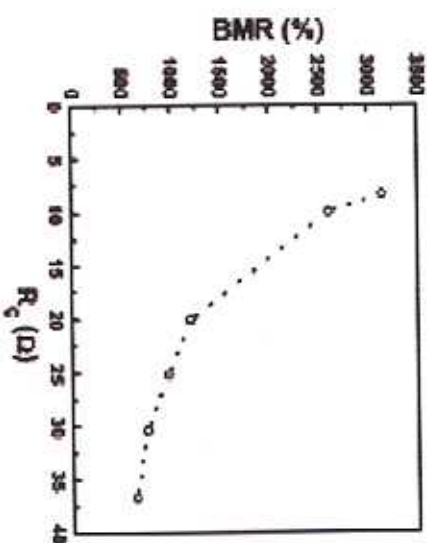
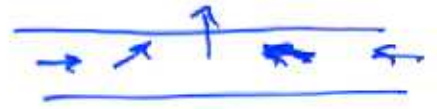
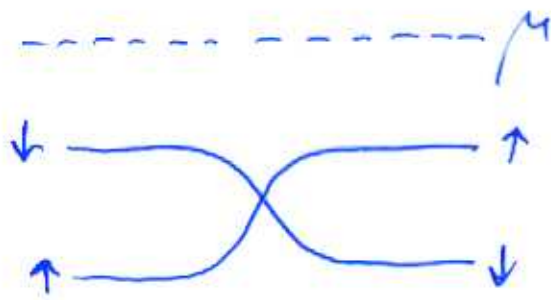
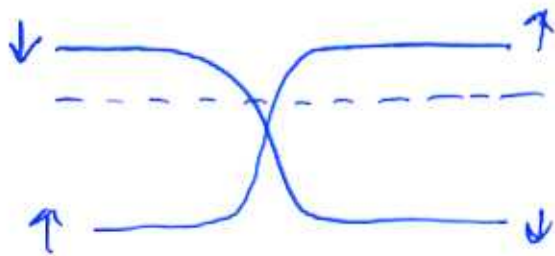


FIG. 4. Variation in BMR as a function of contact radius, as inferred from change in low-field resistance over successive cycles in Fig. 3 and several other measurements taken from the same sample.

Reflection from a sharp domain wall



In case of 100% polarization:



$$MR = \infty$$

